

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Di Gao et al.

Application No.:

Filed: July 3, 2003

For: SELECTIVE ETCHING OF
SILICON CARBIDE FILMS

Examiner:

Art Unit:

INFORMATION DISCLOSURE
STATEMENT UNDER 37 CFR §1.97 and
§1.98

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The references cited on attached form PTO/SB/08A and PTO/SB/08B are being called to the attention of the Examiner. Copies of the references are enclosed. It is respectfully requested that the cited references be expressly considered during the prosecution of this application, and the references be made of record therein and appear among the "references cited" on any patent to issue therefrom.

As provided for by 37 CFR 1.97(g) and (h), no inference should be made that the information and references cited are prior art merely because they are in this statement and no representation is being made that a search has been conducted or that this statement encompasses all the possible relevant information.

Applicants believe that no fee is required for submission of this statement. However, if a fee is required, the Commissioner is authorized to deduct such fee from the

undersigned's Deposit Account No. 20-1430. Please deduct any additional fees from, or credit any overpayment to, the above-noted Deposit Account.

Respectfully submitted,



Babak Kusha
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WC 9060593 v1

Substitute for form 1449/PTO

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

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Page 2 of 3**Complete if Known**

Application Number	
Filing Date	July 3, 2003
First Named Inventor	Gao, Di, et. al.
Art Unit	
Examiner Name	
Attorney Docket Number	18062L-006400

NON PATENT LITERATURE DOCUMENTS

Examiner Initials *	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
	9	CHO et al., <i>Applied Physics Letters</i> , 76(6):739-741 (2000)	
	10	DELSOL et al., <i>Microelectronic Engineering</i> , 50:75-80 (2000)	
	11	DI GAO et al., <i>Applied Physics Letters</i> , 82(11):1742-1744 (2003)	
	12	FLEISCHMAN et al., <i>J. Vac. Sci. Technol. B</i> , 16(2):536-539 (1998)	
	13	HUANG et al., Solid-State Sensor, Actuator and Microsystems Workshop, Hilton Head Island, South Carolina, June 2-6, 2002, pp. 368-369	
	14	HUNG et al., <i>Microelectronic Engineering</i> , 63:405-416 (2002)	
	15	HUNG et al., <i>Solid-State Electronics</i> , 46:791-795 (2002)	
	16	HWANG et al., <i>J. Vac. Sci. Technol. B</i> , 29(6):2199-2205 (2002)	
	17	KHAN et al., <i>Applied Physics Letters</i> , 75(15):2268-2270 (1999)	
	18	KOTZAR et al., <i>Biomaterials</i> , 23:2737-2750 (2002)	
	19	LANOIS et al., <i>Journal of Electronic Materials</i> , 28(3):219-224 (1999)	
	20	LISHAN et al., "InP Processing Using an HBr High Density ICP Plasma," 4 pages (2001)	
	21	LONDON et al., <i>Journal of Propulsion and Power</i> , 17(4):780-787 (2001)	
	22	MEHREGANY et al., <i>International Materials Reviews</i> , 45(3):85-107 (2000)	

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Page **3** of **3****Complete if Known**

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	23 ✓	OKOJIE et al., <i>Sensors and Actuators A</i> , 66:200-204 (1998)	
	24 ✓	SARRO, <i>Sensors and Actuators</i> , 82:210-218 (2000)	
	25 ✓	STOLDT et al., <i>Applied Physics Letters</i> , 79(3):347-349 (2001)	
	26 ✓	STOLDT et al., <i>Sensors and Actuators A</i> , 97-98:410-415 (2002)	
	27 ✓	TANAKA et al., <i>J. Vac. Sci. Technol. B</i> , 19(6):2173-2176 (2001)	
	28 ✓	TANAKA et al., <i>Journal of Microelectromechanical Systems</i> , 10(1):55-61 (2001)	
	29 ✓	YANG et al., <i>Applied Physics Letters</i> , 78(2):162-164 (2001)	
	30 ✓	YIH et al., <i>Phys. Stat. Sol.. B</i> , 202:605-642 (1997)	

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